



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): SATOH, Yoshihiro

Serial No.: 09/981,402

Filed: October 17, 2001

Title: Semiconductor Device and Method for
Its Manufacture

Attorney Docket No.: N320402-00W

Group Art Unit: 2815

Examiner: Richards, D.

NE
13/Response
w/ATT
P. Walker
8-4-03

RESPONSE TO FINAL OFFICE ACTION

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Commissioner for Patents
P.O. Box 1450
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10 A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated May 23, 2003.
The two month Advisory Action period ends July 23, 2003.

15 This response is presented in the revised amendment format set forth in 1265 Off. Gaz.
Pat. Office 87 (Dec. 17, 2002) and so is subject to waiver of the provisions of 37 C.F.R. §1.21(a),
(b) and (c).

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37 C.F.R. §1.8

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35 ☒ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
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Date of Deposit: July 21, 2003

40 Typed/Printed Name: Darryl Walker

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